

Appl. No. 10/075,193

*#8/Collection  
C  
11/22/02  
Hayes*

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. .... 10/075,193  
Filing Date ..... February 13, 2002  
Inventor..... Shenlin Chen et al.  
Assignee..... Micron Technology, Inc.  
Group Art Unit..... 2813  
Examiner ..... Huynh, Y.  
Attorney's Docket No. ..... MI22-1927  
Title: Methods of Forming a Capacitor Structure

**RESPONSE TO NOVEMBER 4, 2002 OFFICE ACTION FAX RECEIVED**

To: Box Non-Fee Amendment  
Assistant Commissioner for Patents  
Washington, D.C. 20231

NOV 20 2002

TECHNOLOGY CENTER 2800

From: Jennifer J. Taylor, Ph.D. (Tel. 509-624-4276; Fax 509-838-3424)  
Wells St. John P.S.  
601 W. First Avenue, Suite 1300  
Spokane, WA 99201-3828

**AMENDMENTS****In the Claims**

Please replace the entire set of claims with the following clean versions of the claims, in accordance with 37 C.F.R. § 1.121(c)(1)(i).

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Patent Application Serial No. .... 10/075,193  
Filing Date ..... February 13, 2002  
Inventor ..... Shenlin Chen et al.  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2813  
Examiner ..... Y. Huynh  
Attorney Docket No. ..... MI22-1927  
Title: Methods of Forming a Capacitor Structure

**FAX RECEIVED**

Assistant Commissioner for Patents  
Washington, D.C. 20231

NOV 20 2002

TECHNOLOGY CENTER 2800

**CERTIFICATE OF FACSIMILE TRANSMISSION UNDER 37 CFR 1.8**

I hereby certify that the following papers are being facsimile transmitted to the Patent and Trademark Office at (703) 872-9318 on the date shown below:

1. Response to November 4, 2002 Office Action

Dated: 11-20-2002

By: Jaime M. White  
Jaime M. White  
Telephone No. (509) 624-4276  
Facsimile No. (509) 838-3424

**NUMBER OF PAGES IN FACSIMILE: 5**